

Serial No. 09/256,265

Docket No. 15917-0011

**PATENT**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Kao et al.  
Serial No: 09/256,265  
Filed: February 23, 1999

Docket No: 15917-0011  
Group Art Unit: 2815  
Examiner: G. Eckert, II

Election  
#3  
6-15-99  
T. Flowers

For: "Method And Apparatus For Split Gate Source Side Injection Flash Memory Cell And Array With Dedicated Erase Gates"

Examiner G. Eckert II  
Group No. 2815  
Assistant Commissioner for Patents  
Washington, D.C. 20231

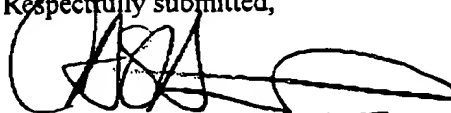
**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

In response to the Restriction Requirement mailed May 10, 1999, Applicant provisionally elects with traverse the claims of Group I; namely, claims 1, 2, and 8-10, drawn to a semiconductor device, classified in class 257, subclass 315.

Applicants respectfully traverses the restriction requirement on the grounds that to be complete, a search for the subject matter of any of the alleged groups would require the same field of search as the other groups. Reconsideration of this requirement is requested.

Respectfully submitted,



Dated: June 9, 1999

Claude A.S. Hamrick  
Registration No. 22,586  
Attorney for Applicant

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JUN 9 1999

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**CERTIFICATE OF MAILING (37 CFR 1.8)**

I hereby certify that this correspondence with all attachments is being sent by facsimile transmission to Examiner G. Eckert, II, Group Art Unit 2815, at (703) 308-7382, Assistant Commissioner for Patents, Washington, D.C. 20231 on June 9, 1999 by I Marie Kotsubo.

Date: June 9, 1999

  
I. Marie Kotsubo

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## FAX COVER LETTER

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June 9, 1999

From : Claude A.S. Hamrick  
Direct Dial : 408-795-3102  
E-Mail : chamrick@owdlaw.com  
Re : Serial No. 09/256,265, Filed February 23, 1999; Kao; "Method and Apparatus  
For Split Gate Source Side Injection..."; Our Docket No. 15917-0011

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PLEASE RUSH TO EXAMINER ECKERT IMMEDIATELY

Completed by : M. Kotsubo / 3126

TO	COMPANY	PHONE NO.	FAX NO.
Examiner G. Eckert, II	U.S. Patent & Trademark Office; Group Art Unit No. 2815	703-305-2752	703-308-7382

Comments : Dear Examiner Eckert: Please find enclosed a Response to Restriction Requirement for the above-identified matter. Please call me with any comments/questions. Regards,  
Claude A.S. Hamrick



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